

<b>Notice of References Cited</b>	Application/Control No. 10/531,129		Applicant(s)/Patent Under Reexamination GUTSOL ET AL.	
	Examiner Ngoc-Yen M. Nguyen		Art Unit 1793	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0086813	05-2003	Fleischer , Werner	422/3
*	B	US-4,181,675	01-1980	Makin et al.	518/705
*	C	US-5,120,771	06-1992	Walmsley, Graham D.	521/107
*	D	US-5,549,795	08-1996	Gregoire et al.	204/164
*	E	US-5,861,123	01-1999	Schiffthner, Kenneth C.	422/24
*	F	US-6,905,577	06-2005	Salama, Amir	204/164
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Sobacchi et al, "Experimental assessment of non-thermal plasma techniques for removal of paper industry VOC emissions", 15th International Symposium on Plasma Chemistry, Orleans, July 9-13, 2001. Symposium Proceedings, Vol. VII: poster contributions, pp. 3135-3140) (taken from <a href="http://plasma.mem.drexel.edu/publications/">http://plasma.mem.drexel.edu/publications/</a> )
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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